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Aine

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[56] References Cited U.S. PATENT DOCUMENTS

[11] E

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[57] ABSTRACT

A thin film of magnetic recording material is sputter deposited over a base layer of gold and tantalum on a polished substrate. A protective layer of gold and tantalum is deposited overlaying the magnetic recording film. A solid lubricant layer such as carbon, preferably in the form of graphite, gold, silver, tin, molybdenum disulfide, and tungsten disulfide is sputter deposited or ion plated over the protective layer to reduce wear. The recording contacting portion of the recording head is similarly coated with a solid lubricant material. Other suitable protective materials include tantalum, niobium, tungsten and nitrides and carbides of such metals. In a preferred method for making such recording members, the layers are successively sputter deposited in an evacuated sputter chamber, whereby the recording layers and protective coatings are formed in a continuous process requiring only one pump down.

29 Claims, No Drawings

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THIN FILM RECORDING AND METHOD OF **MAKING**

Matter enclosed in heavy brackets [] appears in the 5 original patent but forms no part of this reissue specification; matter printed in italics indicates the additions made by reissue.

RELATED CASES

[This is a division, of application Ser. No. 736,814, filed Oct. 29, 1976, U.S. Pat. No. 4,277,540 which inturn was a continuation-in-part of parent application Ser. No. 139,887 filed May 3, 1971, abandoned.

This is a reissue file wrapper continuation of reissue 15 application Ser. No. 691,285, filed Jan. 14, 1985 (now abandoned in favor of the present application) for reissue of U.S. Pat. No. 4,411,963 issued Oct. 25, 1983 and filed July 6, 1981 as a divisional application Ser. No. 280,844 of application Ser. No. 736,814, filed Oct. 29, 1976 and is- 20 sued as U.S. Pat. No. 4,277,540 on July 7, 1981, which in turn was a continuation-in-part of a parent application Ser. No. 139,887 filed May 3, 1971, now abandoned.

DESCRIPTION OF THE PRIOR ART

Heretofore, thin film magnetic recording media, such as discs, drums, tapes and the like have been manufactured by plating extremely thin metallic films of magnetic recording material onto a suitable substrate member. Generally speaking, the metallic magnetic record- 30 ing materials, such as iron, nickel, cobalt or nickelcobalt alloys are deposited to a thickness between two and ten microinches. Such thin films are subject to corrosion in storage and use and, thus, corrosion resistant overcoatings have been applied to a thickness of be- 35 tween two and five microinches. Corrosion resistant materials for the coatings have included rhodium, C,O and SiO.

Such thin magnetic films have typically been deposited by a number of different methods, such as by elec- 40 trochemical deposition, auto catalytic deposition, or vacuum deposition by evaporating the magnetic material in an evacuated chamber and condensing the evaporated material on the substrate. Various magnetic materials and methods for applying same are disclosed and 45 face portion of the magnetic transducer which occadiscussed in an article entitled "A Critical Review of Magnetic Recording Materials" appearing in the IEEE Transactions on Magnetics, Volume MAG-5, #4, of December 1969, pages 821-839. And in an article entitled "An Analysis of High-Coercivity Thin Film Fabri- 50 cation Techniques and Their Associated Properties" appearing in the November-December 1968 issue of Electrochemical Technology, pages 419-427.

Briefly, the greatest problem in utilizing thin film magnetic recording media is the susceptibility of mag- 55 netic recording media to wear. The transducer normally skims between a few microns and several microinches above the magnetic media supported by a thin film of compressed air. Periodically the transducer sinks into contact with the recording media resulting in a 60 high speed impact of the transducer with the recording media. Collisions of this nature cause extreme wear and actual breakdown and destruction of portions of the recording media. Wear of most thin films is usually attributed to the breakdown of adhesion between the 65 metal film and the substrate.

Protective layers deposited over the recording media must be well adhered to the media and have a greater

cohesion than the metal film on which they are deposited or they will compound the problem. In addition, the overcoated protective layers are preferably conductive to prevent the build up of statis electricity. The use of lubricants to minimize the problems of wear and impact has not been satisfactory. Such lubricants often tend to accumulate dust and loose magnetic material on the disc or tape. Debris collected on the transducer can cause severe damage to the magnetic material in an 10 avalanching effect.

The protective overcoating layers should be corrosion resistive and electrically conductive to prevent build-up of static electric charge. Evaporated films exhibit by far the worse wear characteristic compared to electroless and electro plated films, probably due to their porosity and generally poor adhesion to the substrate.

Vacuum deposition is the least complex of the fabrication techniques in that it is truly a one step process. However, vacuum deposited films heretofore have had excess porosity leading to poor wear and corrosion resistance.

Others have attempted to sputter deposit thin films of magnetic recording material onto suitably polished substrates of glass and fused quartz. However, as reported in U.S. Pat. No. 3,148,079 issued Sept. 8, 1964, such prior attempts at sputter depositing magnetic films has not been successful.

SUMMARY OF THE PRESENT INVENTION

The principal object of the present invention is the provision of an improved thin film magnetic recording medium and method of making same.

In one feature of the present invention, the magnetic recording film is covered with a protective coating of gold and tantalum, whereby a protective coating is formed on the magnetic recording film.

In another feature of the present invention, a wear resistant layer of carbon is deposited as by sputtering [on] or ion plating, preferably in the form of graphite, over the thin film of magnetic recording material to protect it from excessive wear.

In another feature of the present invention, the sursionally contacts the recording medium is coated with an adherent solid lubricant layer of carbon preferably in the form of graphite.

In another feature of the present invention, one or more of the layers of the recording medium such as the magnetic recording material, or one or more of its protective coatings, is deposited overlaying a polished surface of the substrate by sputter depositing the respective material over the substrate in a gaseous atmosphere at subatmospheric pressure.

Other features and advantages of the present invention will become apparent upon a perusal of the following specification.

DESCRIPTION OF THE PREFERRED **EMBODIMENTS**

A suitable substrate material such as mylar, in the case of recor ling tape, or aluminum, alumina, beryllia, or glass such as pyroceram, pyrex or the like, is lapped and polished to provide an extremely smooth surface onto which the recording medium is to be deposited. The substrate member is disposed in a chamber which is evacuated to a relatively low pressure, as of 5×10^{-5}

torr. Suitable diffusion pumps and/or getter ion pumps together with liquid nitrogen forepumps and traps are utilized for the pump down of the chamber to assure a clean vacuum and to prevent back streaming of oil from the diffusion pumps. A quartz heating element is placed within the chamber to provide a mild bakeout of the substrate during pump down. After the pressure reaches 5×10^{-5} torr the quartz heaters are turned off and argon is leaked into the chamber through an automatic leak valve to obtain a pressure of 7×10^{-3} torr.

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The evacuated chamber contains any one of a number of different rf induced plasma sputtering electrode arrangements, such as any one or more of those disclosed in an article entitled "Advances In RF-Induced Plasma Sputtering" appearing in SCP and Solid-State Technol- 15 ogy, December, 1967, pages 45-49 and 75. In a preferred embodiment, a plasma coil configuration of the electrodes is employed. Such configuration of electrodes includes a pair of target electrodes made of a material which is to be sputtered onto the substrate. A 20 de bias potential is applied to the target electrodes. Radio frequency energy is applied to a coil interposed between the target electrodes and the substrate. The dc power supply is used to establish a target potential which is negative with respect to the glow discharge.

In the glow discharge, argon ions are created and they are attracted from the plasma to bombard the target electrodes. The ion bombardment of the target electrodes causes the target material to be sputtered therewhich is to be coated. The sputtered target material arrives at the substrate with energies between 30 and 300 electron volts. By causing the target material to be driven onto the substrate, improved density of the deposited layer and improved adhesion between the de- 35 posited layer and the substrate or sublayer is obtained. Both of these characteristics, namely the improvement in density of the layer and of the improved adhesion of the layer to the substrate improves the wear resistance of the resultant recording medium.

A base layer of material (primary coat) which is compatible with the substrate is deposited up to 40 microinches in thickness, preferably in the range of 2 to 10 microinches in thickness. The base metal is selected from the group consisting of molybdenum, titanium, 45 chromium, niobium, tantalum, vanadium and tungsten, and is preferably sputter deposited onto the polished surface of the substrate member. During deposition, relative movement between the substrate and the targets is obtained, as by combined rotation and rectilinear 50 translation of the substrate, to assure uniform deposition of the sputtered material onto the substrate layer. The substrate is preferably first cleaned before depositing the base layer by sputter etching the surface, i.e. reverscomes the target.

The magnetic recording layer is deposited over the base layer. In a preferred embodiment, target electrodes of magnetic material are substituted for the original targets, as by flipping over the targets or by using other 60 targets, for depositing a thin film of magnetic recording material onto the base layer. For example, a suitable magnetic material is selected from the class consisting of iron, nickel, cobalt or alloys thereof. In a preferred embodiment a nickel-cobalt alloy consisting of 30% 65 nickel and 70% cobalt is sputter deposited onto the base layer to a thickness of between 2 and 15 microinches and preferably to a thickness of approximately 5 micro-

inches. Relative movement between the target and the substrate is produced, as aforedescribed, to obtain uniform thickness of the deposited layer over the surface to be coated. Alternatively, the magnetic layer is deposited by the conventional electroless process.

A corrosion resistant protective layer is deposited, preferably by sputtering, over the magnetic layer to a thickness between 2 and 10 microinches and preferably approximately 5 microinches. Suitable corrosion resis-10 tant materials include gold, tantalum, niobium, platinum, chromium, tungsten and rhodium.

However, a corrosion resistant layer of gold and tantalum, preferably obtained by co-sputter deposition, is especially effective in preventing corrosion products from permeating the gold and tantalum layer into the magnetic material. The precise mechanism of how gold and tantalum serves to especially inhibit corrosion and corrosion products from diffusion through the layer to the substrate is not understood. The tantalum forms a very hard tightly adherent wear resistant and corrosion resistant layer on the magnetic layer. Gold infiltrates into the grain boundaries to inhibit permeation by corrosion products, such as hydrogen. Gold also serves as a solid lubricant on the outer surface of the gold and 25 tantalum layer. Sputter deposited gold, as a solid lubricant, has increased adhesion to the tantalum and magnetic layers, thereby reducing the tendency for the gold to agglomerate on the surface of the recording medium.

A tantalum or tantalum and gold base layer (primary from and to be collected or deposited upon the substrate 30 coat) is especially advantageous with use of a tantalum or tantalum and gold protective coating since such a base layer protects the magnetic layer from corrosion products diffusing from the substrate into the magnetic

> Alternatively, a corrosion resistant and wear resistant protective coating is obtained by reactively sputter depositing refractory nitrides or refractory carbides, such as nitrides or carbides of Si, Zr, Hf, Ti, Ta, W and Nb to a thickness of between two and ten microinches, 40 preferably four microinches, onto the sputter etched or cleaned magnetic layer and then stabilizing the protective layer by growing an anodic oxide layer thereon to a thickness of approximately one to two microinches and annealing same at 250°-400° C. for five hours. Such carbide and nitride tantalum and niobium layers are anodized by an aqueous solution of 0.1% H₃PO₄. Such refractory nitrides and carbides are obtained by introducing N₂ or ethane or methane into the argon glow discharge used to sputter deposit the other constituents of the nitride or carbide. See Electrochemical Technology, July-August, 1968 issue, pages 269 et seq. Tungsten carbide reactively sputter deposited, as abovedescribed, also provides a wear resistant coating.

As aforementioned, gold provides a solid lubricant ing the d.c. bias potential such that the substrate be- 55 for reducing friction and thus wear. Other solid lubricants include silver, carbon (especially in the form of graphite), MoS2, Sn and WS2. Such lubricants are preferably sputter deposited to a thickness of one to five microinches over the aforedescribed protective layer. Sputter deposition of the lubricants serves to improve the adhesion of the lubricant to the sublayer, thereby increasing the wear resistance of the protective coatings. Of the solid lubricants, gold and graphite are particularly desirable. Graphite and carbon are particularly suitable for deposition on sublayers comprised of carbide formers such as Si, Zr, Hf, Ti, Ta, Nb and W.

> The magnetic transducer head portion which occasionally sinks into contact with the recording medium is

preferably formed of or coated with carbon, preferably in the form of graphite, to provide a low friction wear resistant contacting surface with the recording medium.

As an alternative to sputter depositing the carbon onto the sublayer, the low friction carbon layer may be 5 formed by ion plating according to the method disclosed in U.S. Pat. Nos. 3,329,601 or 3,386,909. The use of sputter deposition or ion plating of the carbon coating results in a tightly adherent coating of the carbon on

The advantage to the use of sputter deposition for depositing the successive layers of materials onto the substrate member of the recording medium is that such layers may be deposited in a one-step method where the down within the evacuated chamber. In addition, use of sputter deposition aparatus allows the substrate surfaces and the surfaces of subsequent layers which are to be coated to be cleaned first by bombarding the surface to be coated with ions for cleaning away contaminants that may be present on the surface to be coated. In this manner tightly adherent wear resistant and relatively non porous coatings are obtained.

What is claimed is:

- 1. In a magnetic recording medium, a substrate member, a film of magnetic recording material overlaying said substrate, and a protective layer of gold and tantalum overlaying said film of magnetic recording material.
- 2. The recording medium of claim 1 including a lubricant layer of carbon overlaying said protective layer.
- 3. The recording medium of claim 2 wherein said layer of carbon is in the form of graphite.
- layer of carbon is bonded to the adjacent sublayer on said substrate member.
- 5. The recording medium of claim 1 wherein said substrate is made of a material selected from the class consisting of ceramic, aluminum, and glass, said sub- 40 tantalum. strate having a polished surface, and wherein said magnetic film is deposited to a thickness between 2 and 15 microinches overlaying said polished surface of said
- dium, depositing a film of magnetic recording material onto a substrate member, and depositing a layer of gold and tantalum over said film of magnetic recording mate-
- 7. The method of claim 6 wherein said layer of gold 50 and tantalum is deposited by sputtering gold and tantalum over said magnetic film in a gaseous atmosphere at subatmospheric pressure.
- 8. The method of claim 6 including the step of, deposlum.
- 9. The method of claim 8 wherein said layer of carbon is deposited by sputtering carbon over said gold and tantalum in a gaseous atmosphere at subatmospheric
- 10. The method of claim 9 wherein said carbon is sputtered from a graphite target by ion bombardment to form a graphite layer of carbon over said gold and
- 11. The method of claim 8 wherein said layer of car- 65 bon is deposited by ion plating carbon over said gold and tantalum layer from a glow discharge in a gaseous atmosphere at subatmospheric pressure.

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- 12. In a method for making a magnetic recording medium the steps of, depositing at subatmospheric pressure a base layer of a metal selected from the group consisting of molybdenum, titanium, chromium, niobium, tantalum, vanadium, and tungsten overlaying a substrate member, said substrate member comprising a material selected from the class consisting of ceramic, aluminum and glass, depositing at subatmospheric pressure a film of magnetic recording material over said first 10 layer, and depositing at subatmospheric pressure a protective layer of material selected from the class consisting of niobium, tantalum, and tungsten over said magnetic recording film.
- 13. The method of claim 12 including the step of recording medium need only be subjected to one pump 15 forming a solid lubricating layer selected from the class consisting of carbon, graphite, molybdenum disulfide, tin, gold, silver, and tungsten disulfide over said protective layer.
 - 14. The method of claim 13 wherein said base, magnetic, protective, and lubricating layers are all deposited by sputtering said respective materials onto said substrate from respective targets in a gaseous atmosphere at subatmospheric pressure.
 - 15. The method of claim 12 wherein said base, mag-25 netic, and protective layers are all deposited by sputtering said respective materials onto said substrate from respective targets in a gaseous atmosphere at subatmospheric pressure.
 - 16. The method of claim 12 wherein said step of depositing a protective layer comprises the step of depositing a layer of gold and tantalum over said magnetic recording layer with the proportion of gold in the layer increasing in a direction taken away from the direction of the magnetic recording layer, whereby the propor-4. The recording medium of claim 2 wherein said 35 tion of gold increases at the outer surface to form a lubricating coating over a wear resistant and corrosion resistant protective layer.
 - 17. The method of claim 12 wherein each of said base and protective layers comprises a layer of gold and
 - 18. In a method for making a recording medium, the steps of, growing a film of recording material onto a substrate member, and growing a protective layer of material over said film of recording material, such pro-6. In a method for making a magnetic recording me- 45 tective layer being selected from the class consisting of niobium, tantalum, tungsten, refractory carbides and refractory nitrides.
 - 19. The method of claim 18 including the step of anodizing the protective layer.
 - 20. The method of claim 18 wherein the step of growing the protective layer comprises the step of sputter depositing said protective layer.
 - 21. The product made by the method of claim 18.
- 22. The method of claim 18 wherein said protective iting a layer of carbon over said layer of gold and tanta- 55 layer is selected from the group consisting of silicon nitride and silicon carbide.
 - 23. In a method for protecting a magnetic recording disc of the type having a disc-shaped substrate coated with a continuous, non-particulate film of magnetic recording 60 medium, the steps of:
 - exciting a gaseous atmosphere at subatmospheric pressure with an electrical discharge;
 - sputtering carbon within said excited gaseous atmosphere at subatmospheric pressure; and
 - depositing a film of the sputtered carbon onto the coated substrate and tightly adhering the sputtered carbon film to the coated substrate in overlaying relationship with the film of magnetic recording medium to form

a tightly adherent wear-resistant carbon film on the coated substrate for causing the magnetic recording disc to be wear-resistant.

24. The product made by the method of claim 23.

25. The method of claim 23 wherein said wear resistant 5 film of carbon is deposited by sputtering carbon from a carbon target, disposed within said gaseous atmosphere at subatmospheric pressure, onto the substrate in overlaying relationship with said film of magnetic recording medium.

26. The method of claim 23 including the step of adher- 10 strate, the steps of: ing the carbon film directly onto a layer of a carbide former sputter depositing

material on the disc.

27. In a method for protecting a magnetic recording disc of the type having a disc-shaped substrate coated with a continuous non-particulate film of magnetic recording 15 medium, the steps of:

exciting a gaseous atmosphere at subatmospheric pressure with an electrical discharge; and

ionizing carbon within said excited gaseous atmosphere at subatmospheric pressure; and

plating a film of the ionized carbon onto the coated substrate in overlaying relationship with the film of magnetic recording medium to form a tightly adherent wear-resistant carbon layer on the coated substrate for causing the resultant magnetic recording disc to be wear-resistant.

28. The product made by the method of claim 27.

29. In a method for making a magnetic recording disc of the type having a disc-shaped, polished, aluminum substrate, the steps of:

sputter depositing a film of chromium overlaying the

sputter depositing a film of cobalt alloy as the magnetic recording layer and adhering the cobalt film directly to said chromium film; and

sputter depositing a tightly adherent wear resistant film of carbon onto the substrate in overlaying relationship with the cobalt alloy film for causing the resultant magnetic recording disc to be wear resistant.

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